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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/813,682	03/31/2004	Engelbertus Antonius Fransiscus Van Der Pasch	081468-0308989	4356
909	7590	06/21/2005		EXAMINER
PILLSBURY WINTHROP SHAW PITTMAN, LLP				SOUW, BERNARD E
P.O. BOX 10500				
MCLEAN, VA 22102				ART UNIT
				PAPER NUMBER
				2881

DATE MAILED: 06/21/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No.	Applicant(s)	
	10/813,682	VAN DER PASCH ET AL.	
	Examiner	Art Unit	
	Bernard E. Souw	2881	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) Responsive to communication(s) filed on 31 March 2004.
- 2a) This action is FINAL. 2b) This action is non-final.
- 3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) Claim(s) 1-22 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) Claim(s) _____ is/are allowed.
- 6) Claim(s) 1-22 is/are rejected.
- 7) Claim(s) _____ is/are objected to.
- 8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) The specification is objected to by the Examiner.
- 10) The drawing(s) filed on 31 March 2004 is/are: a) accepted or b) objected to by the Examiner.
 Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
 Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) All b) Some * c) None of:
1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. _____.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413) |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Mail Date. _____ |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date _____ | 5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
| | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Specification

1. The lengthy specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

2. Claims 1-3 and 12-14 are rejected under 35 U.S.C. 102(b) as being anticipated by Hill (USPAT 6,137,574).

Hill discloses a lithographic apparatus and method shown in Fig.1, comprising a radiation source 1 configured to provide radiation 9 to an illumination system, as recited in Col.6/II.25-30 and Col.6/II.35-45, the radiation source 1 configured to provide radiation in a first wavelength range λ_1 and in a second wavelength range λ_2 , the second wavelength range being different from the first wavelength range, as recited in Col.6/II.18-20 and Col.15/II.37-45, with a basic arrangement depicted in Fig.1A and recited in Col.17/II.46-60; a support configured to support a patterning device, the

patterning device configured to impart the radiation with a pattern in its cross-section; a substrate table configured to hold a substrate; a projection system configured to project the patterned radiation onto a target portion of the substrate, as recited in Col.79/II.35-49 (claim 44).

- ▶ Regarding claims 2 and 13, Hill's system or method shown in Fig.9A employs a filter (879A-D) shown in Fig.9A and recited in Col.65/II.8-26 + 65-67 and Col.66/II.4-5, and/or filter 882M shown in Fig.9A and recited in Col.66/II.33-46.
- ▶ Regarding claims 3 and 14, Hill's system or method shown in Fig.9A employs a radiation director (either one of 841F, 853B-D or 851A-F in Fig.9A) to direct radiation from the second radiation source element to the illumination system.

Claim Rejections - 35 USC § 103

3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

4. Claims 5-8, 11, 16-19 and 22 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hill.

Hill inherently encompasses all the limitations of claims 5-8, 11, 16-19 and 22, since Hill's radiation source is not restricted to one wavelength (range) only, but includes the entire wavelength range from x-ray, over XUV, EUV (including 13 nm), VUV (including 157 nm to 193 nm), as well as UV (including 150 nm to 350 nm), as

recited in Col.71/ll.62-65 and Col.10-13, wherein the optics for use in the respective wavelength ranges are all conventional and well known in the art, as expressly recited by Hill in Col.74/ll.4-8.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to employ the specific optics appropriate to each respective wavelength range, in order to have maximum transmission and lithographic projection, recited by Hill in Col.74/ll.4-8.

One of ordinary skill in the art would have been motivated to modify Hill's versatile and complicated system or method in its various embodiments by eliminating elements or steps that are not needed, since omission of an element and/or its function is obvious if the function of the element is not desired/required/intended. *Ex Parte Wu*, USPQ 2031 (Bd. Pat. App. & Inter. 1989).

5. Claims 4, 9, 15 and 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hill in view of Li (USPAT 5,926,298) or Kawakubo (USPAT 6,219,130) or Tanimoto et al. (USPAT 4,870,452) or Nishi (USPAT 5,138,176) or Nakagawa et al. (USPAT 5,184,196) or Nara et al. (USPAT 5,850,279).

Hill discloses all the limitations of claims 4, 9, 15 and 20, as previously applied to the parent claims 1 and 12, except the recitation of specific limitations that are respectively obvious over either one or more of the secondary prior art references cited above, to be individually described as follows:

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- Li uses the first wavelength range for pattern exposure, while using the second wavelength range for performance test, as recited in Col.5/II.2-10.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for performance test, in order the two radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

- Kawakubo uses the first wavelength range for pattern exposure, while using the second wavelength range for alignment, as recited in Col.13/line 47 (claim 1).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for alignment, in order the two radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

- Tanimoto et al. use the first wavelength range for pattern exposure, while using the second wavelength range for alignment, as recited in Col.1/II.62-68 and Col.2/II.1-4.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for alignment, in order the two radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

- Nishi uses the first wavelength range for pattern exposure, while using the second wavelength range for alignment, as recited in Col.3/II.55-64.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for alignment, in order the two

radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

- Nakagawa et al. use the first wavelength range for pattern exposure, while using the second wavelength range for alignment, as recited in Abstract/II.1-9.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for alignment, in order the two radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

- Nara et al. use the first wavelength range for pattern exposure, while using the second wavelength range for alignment, as recited in Col.1/II.27-34.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for alignment, in order the two radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

In adopting the teaching of each of the secondary prior art(s), one of ordinary skill in the art would have been motivated to eventually take only the secondary teaching of using the second wavelength, while still using the first wavelength according to Hill's, since omission of an element and/or its function is obvious if the function of the element is not desired-required/intended. *Ex Parte Wu*, USPQ 2031 (Bd. Pat. App. & Inter. 1989).

- Specifically regarding claims 4 and 15, application of the first wavelength range for exposure is conventionally performed under controlled environment, in order to

achieve high accuracy of pattern transfer, whereas the alignment process with a second wavelength range may be conducted when the controlled environment is not established.

6. Claims 10 and 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hill in view of Stryer et al. (USPGPUB 2002/0064796).

Hill discloses all the limitations of claims 10 and 21, as previously applied to the parent claims 1 and 12, except the recitation of specific limitation of using the first wavelength range for exposing a first pattern on a first substrate, while using the second wavelength range for making a second exposure on a second substrate

Stryer et al. use the first wavelength range for exposing a first pattern on a first substrate, while using the second wavelength range for making a second exposure on a second substrate, as recited on pg.19, column 1, claim 42.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use a second wavelength range for a second exposure on a second substrate, in order the two radiations of different wavelengths do not interfere with each other, as taught by Li in Col.5/II.6-10.

Double Patenting

Non-Statutory Type Double Patenting

7. The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent

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and to prevent possible harassment by multiple assignees. See *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and, *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent is shown to be commonly owned with this application. See 37 CFR 1.130(b).

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

Obviousness Type Double Patenting

8. Claim 1 is provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claim 1 of copending Application No. 10/792,909, filed 03/05/2004, issued as USPGPUB 2005/0110965 to the same Assignee. Although the conflicting claims are not identical, they are not patentably distinct from each other because the limitation of claim 1 of the reference US applications is narrower than that of present claim 1. Since the reference application is filed earlier (03/05/2004) than the present application (03/31/2004), according to the MPEP a broader claim stands in conflict with a narrower claim that is filed on an earlier date.

This is a provisional obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

9. Claim 2 is provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claim 1 of copending Application No. 10/952,214, issued as USPGPUB 2005/0078292 to the same Assignee. Although the conflicting claims are not identical, they are not patentably distinct from each other because the present claim 2 includes the same limitations as claim 1 of the reference US application, which was filed later (08/25/2004) than the present Application. Therefore, the present claim 2 is an obvious variation of the reference claim 1.

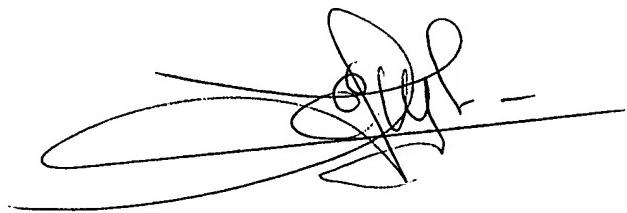
This is a provisional obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

Communications

10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Bernard E Souw whose telephone number is 571 272 2482. The examiner can normally be reached on Monday thru Friday, 9:00 am to 5:00 pm..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R Lee can be reached on 571 272 2477. The central fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306 for regular communications as well as for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 308 0956.

A handwritten signature in black ink, appearing to read "Bernard E. Souw", is written over a horizontal line.

Bernard E. Souw

Patent Examiner – AU 2881

June 17, 2005